

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/686,794	HSIEH, CHIA-TA
	Examiner	Art Unit
	Scott R. Wilson	2826

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
253	300, 288 314, 324	3/3/05	Sims
	327, 368 239, 261	/	
	315-326		
438	201, 211 257		
711	103	↓	↓